

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

priority Application Serial No. 10/075,172
Confirmation No. unknown
priority Filing Date February 13, 2002
Inventor..... B. E. Cron
Assignee.....Micron Technology, Inc.
Group Art Unit..... unknown
Examiner unknown
Attorney's Docket No.MI22-2430
Customer No:021567
Title: Methods for Conditioning Surfaces of Polishing Pads After Chemical-Mechanical
Polishing

PRELIMINARY AMENDMENT

To: Mail Stop Patent Application
Commissioner for Patents
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AMENDMENTS

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